

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Jaime Poris

Assignee:

Nanometrics Incorporated

Title:

Method of Measuring Dishing

Serial No.:

09/578,798

Filing Date:

May 23, 2000

Examiner:

William C. Choi

Group Art Unit:

2873

Docket No.:

NAN040 US

Confirmation No:

5190

Santa Clara, California March 24, 2003

COMMISSIONER FOR PATENTS Washington, D. C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97(c)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the documents listed on the accompanying Form PTO-1449. A copy of the documents is also submitted herewith. The Examiner is requested to make this document of record.

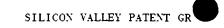
This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(c) as it is after receipt of a first Office Action on the merits but before mailing of a final Action or Notice of Allowance. Accordingly, a fee is required pursuant to 37 CFR §1.17(p). A Fee Transmittal form (PTO/SB/17) is attached to this submission.

The attached Form PTO-1449 lists references 3 through 7. Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The information contained in this Information Disclosure Statement under 37 C.F.R. §1.555 is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the

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Application No. 09/578,798



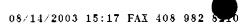
like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Via Express Mail Label No. EU 227 021 194 US Respectfully submitted,

Michael J. Halbert Attorney for Applicants Reg. No. 40,633

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Sheet 1 of 1

	U.S. Department of Commerce, Patent and Trademark Office							09/578,798		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)						Filing Date:			May 23, 2000	
						First Named Inventor:			Jaime Poris	
						Group Art Unit:			2873	
						Examiner Name: Confirmation No.:		William C. Choi		
			U.S. Pate	ent Documents				, , , , , , , , , , , , , , , , , , ,		
Examiner Initial		Document Number	Date	Name		Class	Ş	ubclass	Filing Date If Appropriate	
	3.	5,348,002	9/20/94	Саго		128		633		
	4.	5,555,471	Sep/10/96	Xu et a	1.	356		357		
	5.	5,914,782	Jun/22/99	Sugiyar	na	356		351		
	6.	6,392,752	5/21/02	Johnso	מי	356		511		
	1	OTHER .	ART (Including Aut	nor, Title, Date	e, Pertiner	t Pages, Et	c.)			
Examiner			Date Considered							
		tial if reference is cons								